

Type	Hits	Search Text	DBs	Time Stamp
1 BRS	33	rosencwaig.in. rosencwaig.in. and semiconductor	USPAT	2002/06/24 10:01
2 BRS	25	(rosencwaig.in. and semiconductor) and gas\$5	USPAT	2002/06/24 10:02
3 BRS	8	((rosencwaig.in. and semiconductor) and gas\$5) and microwave	USPAT	2002/06/24 09:48
4 BRS	0		USPAT	2002/06/24 09:49
5 BRS	0	((rosencwaig.in. and semiconductor) and gas\$5) and (reduce adj thickness)	USPAT	2002/06/24 09:49
6 BRS	7	((rosencwaig.in. and semiconductor) and gas\$5) and (thickness)	USPAT	2002/06/24 10:02
7 BRS	4	(((rosencwaig.in. and semiconductor) and gas\$5) and (thickness)) and (probe adj beam)	USPAT	2002/06/24 10:02
8 BRS	50	rosencwaig.in. or opsal.in. ((rosencwaig.in. and semiconductor) and gas\$5) and (thickness)) and (thickness and (probe adj beam))	USPAT	2002/06/24 10:01
9 BRS	4	(((rosencwaig.in. and opsal.in.) and (thickness and (probe adj beam))) ((rosencwaig.in. or opsal.in.) and semiconductor)) and (thickness and (probe adj beam)))	USPAT	2002/06/24 10:03
10 BRS	30	(((rosencwaig.in. or opsal.in.) and semiconductor)) and (thickness and (probe adj beam)))	USPAT	2002/06/24 10:03
11 BRS	8	(((rosencwaig.in. or opsal.in.) and semiconductor) and (thickness and (probe adj beam))) and gas\$4	USPAT	2002/06/24 14:43
12 BRS	5488	semiconductor and wafer and microwave semiconductor and wafer and microwave and (semiconductor and wafer and microwave) and (thickness and (probe adj beam))	USPAT; EPO; JPO; DERWENT	2002/06/24 14:43
13 BRS	20	rosencwaig.in. or opsal.in.) and semiconductor ((rosencwaig.in. or opsal.in.) and semiconductor)	USPAT; EPO; JPO; DERWENT	2002/06/24 17:16
14 BRS	40	((rosencwaig.in. or opsal.in.) and semiconductor (rosencwaig.in. or opsal.in.) and semiconductor) and (probe adj beam))	USPAT	2002/06/24 16:34
15 BRS	36	((("5798837") or ("5449411") or ("5439596") or ("5306671") or ("5261965") or ("5049816") or ("38887392"))).PN.	USPAT	2002/06/30 19:29
16 IS&R	7	((("5798837") or ("5449411") or ("5439596") or ("5306671") or ("5261965") or ("5049816") or ("38887392"))).PN.	USPAT	2002/06/24 17:21
17 BRS	6	((("5798837") or ("5449411") or ("5439596") or ("5306671") or ("5261965") or ("5049816") or ("38887392"))).PN.) and microwave	USPAT	2002/06/24 17:29
18 BRS	5	((("5798837") or ("5449411") or ("5439596") or ("5306671") or ("5261965") or ("5049816") or ("38887392"))).PN.) and microwave and gas\$5	USPAT	2003/09/04 16:13
19 BRS	13	spectrophotometer and ellipsometer and (probe adj beam)	USPAT; EPO; JPO; DERWENT	2002/06/30 19:32
20 BRS	1	(spectrophotometer and ellipsometer and (probe adj beam)) and cleaning	USPAT; EPO; JPO; DERWENT	2002/06/30 19:32
21 BRS	67	ellipsometer and (probe adj beam)	USPAT; EPO; JPO; DERWENT	2002/06/30 19:32

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22	BRS	5	(ellipsometer and (probe adj beam)) and cleaning	USPAT; EPO; JPO; DERWENT	2002/06/30 19:32
23	BRS	30	((rotating adj compensator) and (rotating adj analyzer)) and (rotating adj beam)	USPAT; EPO; JPO; DERWENT	2002/06/30 19:51
24	BRS	12	((rotating adj compensator) and (rotating adj analyzer)) and (probe adj beam)	USPAT; EPO; JPO; DERWENT	2002/12/15 20:33
25	BRS	9	(carbon adj dioxide adj pellets) and semiconductor and wafer	USPAT; EPO; JPO; DERWENT	2002/07/01 03:08
26	IS&R	1	("5261965").PN.	USPAT	2002/07/01 04:29
27	BRS	1	((("5261965") PN) and microwave	USPAT	2002/07/01 03:17
28	BRS	1	((("5261965").PN.) and microwave) and heat	USPAT	2002/07/01 03:17
29	BRS	1	5261965. pn. and vacuum	USPAT	2002/07/01 05:13
30	BRS	1	5798837. pn. and polychromatic	USPAT	2002/07/01 05:14
31	BRS	1	5798837. pn. and uv	USPAT	2002/07/01 05:14
32	BRS	0	((rotating adj compensator) and (rotating adj analyzer)) and (probe adj beam) and transport	USPAT; EPO; JPO; DERWENT	2002/12/15 20:34
33	BRS	1927	356/237.2-237.5.369,432.ccls.	USPAT	2003/09/04 16:02
34	BRS	1391	356/237.2-237.5.369,432.ccls. and @ad<19980928	USPAT	2003/09/04 16:04
35	BRS	95	(356/237.2-237.5.369,432.ccls. and @ad<19980928) and cleaning	USPAT	2003/09/04 16:04
36	BRS	0	((356/237.2-237.5.369,432.ccls. and @ad<19980928) and cleaning) AND spectrophotometer and ellipsometer and (probe adj beam)	USPAT; EPO; JPO; DERWENT	2003/09/04 16:14
37	BRS	2	((356/237.2-237.5.369,432.ccls. and @ad<19980928) and cleaning) AND spectrophotometer and (probe adj beam)	USPAT	2003/09/04 16:14
38	BRS	3	((356/237.2-237.5.369,432.ccls. and @ad<19980928) and cleaning) and (probe adj beam)	USPAT	2004/07/23 09:40
39	IS&R	2	((("5798837") or ("5261965")).PN.	USPAT	2004/07/23 08:12
40	BRS	2	(optical adj inspection adj system) and (cleaning adj system)	USPAT; US-PGPUB	2004/07/23 09:17
41	BRS	135	(spectrophotometer or ellipsometer) and (cleaning adj system)	USPAT; US-PGPUB	2004/07/23 08:19
42	BRS	50	((spectrophotometer or ellipsometer) and (cleaning adj system)) and @ad<19980928	USPAT; US-PGPUB	2004/07/23 09:17
43	BRS	11	((spectrophotometer or ellipsometer) and (cleaning adj system)) and @ad<19980928 and (semiconductor or wafer)	USPAT; US-PGPUB	2004/07/23 09:14

	Type	Hits	Search Text	DBs	Time Stamp
44	IS&R	1	("6714884").PN. (" and clean\$4").PN.	USPAT	2004/07/23 09:14
45	IS&R	0	(" and clean\$4").PN.	USPAT	2004/07/23 09:14
46	BRS	1	(("6714884").PN.) and clean\$4 (optical adj inspection adj system) and (cleaning adj system)	USPAT	2004/07/23 09:15
47	BRS	0		EPO; JPO; DERWENT	2004/07/23 09:17
48	BRS	1	((spectrophotometer or ellipsometer) and (cleaning adj system)) and @ad<19980928	EPO; JPO; DERWENT	2004/07/23 09:17
49	BRS	27	((356/237.2-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer)	USPAT; US-PGPUB	2004/07/23 10:00
50	BRS	19	((356/237.2-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer) and (semiconductor or wafer)	USPAT; US-PGPUB	2004/07/23 10:00
51	BRS	33	((356/237.1-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer)	USPAT; US-PGPUB	2004/07/23 10:00
52	BRS	21	((356/237.1-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer) and (semiconductor or wafer)	USPAT; US-PGPUB	2004/07/23 10:00
53	BRS	2	((356/237.1-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer) and (semiconductor or wafer)) not ((356/237.2-237.5.369,432.ccls. and @ad<19980928) and clean\$4) and (spectrophotometer or ellipsometer) and (semiconductor or wafer))	USPAT; US-PGPUB	2004/07/23 10:01
54	IS&R	8	("3,887,392") or ("5,261,965") or ("5,306,671") or ("5,316,970") or ("5,439,596") or ("5,449,411") or ("5,798,837") or ("6,325,078").PN.	USPAT	2004/07/23 10:02